

Receipt date: 02/07/2007
FEDFORM PTO-1449

REFORM PTO-1449

10583942 - GAU: 1792

Sheet 1 of 1



INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Attorney Docket No.:
8007-1111

Application No.:
10/583,942

Applicant:
Atsushi SAKURAI et al.

Filing Date:
June 22, 2006

Group Art Unit:
2812

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

LEE et al., "Effect of the precursors on the deposition of (Ba,Sr)TiO₃ films," *J. Phys. IV France*, Vol. 11, 2001, pp. Pr3-215-222.

EXAMINER: /Joel Horning/

DATE CONSIDERED

04/29/2009

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

BClink

Y&T February 7, 2007

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.H./